Y-Branch optical modulator

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ABSTRACT

To characterize z-cut Ti:LiNbO₃ Y-branch optical modulators, numerical simulations were performed showing that high on/off ratios are attainable without special Y-junction asymmetries or long electrodes. The effective index and 2-D finite difference beam propagation methods were used for the simulations. A modulator with a 2° Y-branch was fabricated. The measured on/off ratios were 5:1 at 25 V, 12:1 at 50 V, and 60:1 at 75 V, corresponding to 4:1, 12:1, and 62:1 for the simulations for λᵣ = 632.8 nm.

1. INTRODUCTION

Increasing research is being done in the area of electro-optic modulators in part due to their potential use in time division multiplexers¹ as well as in digital switches² for high bit rate optical communications. Y-branch optical modulators are more suitable for such use than Mach-Zehnder type modulators because they are easier to fabricate and to control. Y-branch optical modulators are non-interferometric by nature and are tolerant of variations in parameters such as applied voltage, branch angle, and wavelength.

The Y-branch optical modulator operates by the electro-optic effect. In its neutral state, without any voltage application, each branch arm guides an equal amount of light. Application of voltage to its electrodes channels light into one of the arms of the Y-branch while at the same time channelling light out of the other arm. The arm to which the light is channelled or not channelled depends on the polarity of the applied voltage.

We examine, both numerically and experimentally, a Y-branch optical modulator fabricated in z-cut lithium niobate (LiNbO₃), where the waveguides are formed by titanium (Ti) indiffusion. Previous devices with high on/off ratios have had very small branch angles³ (i.e., less than 0.2°) and/or asymmetric branch arms⁴. Small branch angles give rise to long devices and long electrodes resulting in wasted real estate on the LiNbO₃ substrate and increased capacitance. Furthermore, asymmetric branches are more difficult to fabricate. Here, we show that devices with high on/off ratios can be obtained without long horn lengths or any special Y-junction asymmetries.
2. NUMERICAL SIMULATIONS

Although there are 3-D numerical methods which can simulate a propagating optical field within a waveguide, a 2-D beam propagation method (BPM) is chosen due to its increased speed and comparable accuracy\(^5\). The effective index method\(^6\) (EIM) is first applied to reduce the refractive index profile from 3-D to 2-D. The refractive index \(n(x,z)\) for metal indiffused strip waveguides (here, we use \(z\) instead of \(y\) to indicate the \(z\)-axis of the LiNbO\(_3\)) is defined as follows\(^6\):

\[
n^2(x,z) = n_b^2 + (n_s^2 - n_b^2) f\left(\frac{z}{D}\right) g\left(\frac{2x}{W}\right) \tag{1a}
\]

where

\[
f\left(\frac{z}{D}\right) = \exp\left(-\frac{z^2}{D^2}\right) \tag{1b}
\]

and

\[
g\left(\frac{2x}{W}\right) = \frac{1}{2} \left\{ \text{erf}\left[\frac{W}{2D}\left(1 + \frac{2x}{W}\right)\right] + \text{erf}\left[\frac{W}{2D}\left(1 - \frac{2x}{W}\right)\right] \right\} \tag{1c}
\]

where \(D\) is the diffusion depth, \(W\) is the width of the Ti strip prior to diffusion, \(n_b\) is the bulk refractive index for \(z\)-cut LiNbO\(_3\) at \(\lambda = 632.8\) nm, and \(n_s\) is the maximum refractive index at the surface due to the Ti indiffusion. The device configuration and fabrication parameters of the Y-branch optical modulator are given in Figure 1 and Table I respectively.

After using the EIM to reduce the refractive index profile, giving the effective index \(n_{\text{eff}}(x)\) from \(n(x,z)\), the finite difference beam propagation method\(^7\) (FDBPM) is used to calculate the optical field distribution. The FDBPM is based on the Fresnel approximation to the scalar Helmholtz equation. The evolution of the electric field for a single polarization of a monochromatic optical wave in our case is\(^7\):

\[
\mathcal{E}(x,y+\Delta y) = \left[ D_x e^{-\frac{ik}{2n_b^2} \int_{y'}^{y+\Delta y} (n_{\text{eff}}^2(x,y') - n_b^2) \, dy'} \right] e^{-ikn_s \Delta y} \mathcal{E}(x,y) + O(\Delta y)^3 \tag{2a}
\]

where

\[
D_x = \frac{1 + \frac{-i\Delta y}{8k_0n_b} \frac{\partial^2}{\partial x^2}}{1 + \frac{i\Delta y}{8k_0n_b} \frac{\partial^2}{\partial x^2}} \tag{2b}
\]
Figure 1  Dimensions and fabrication parameters of the Y-branch optical modulator.

Figure 2  On/off ratios and percent guided power vs. applied voltage for the 2° Y-branch optical modulator for $\lambda_o = 632.8$ nm.
The FDBPM is chosen over the BPM because it remains accurate for larger longitudinal step lengths\(^8\) and therefore it is considerably faster.

To simulate the effect of voltage application to the electrodes of the Y-branch optical modulator, conformal mapping\(^9\) is used to calculate the electric field components in the \(x\) and \(z\) directions in the electro-optic substrate, \(E_x\) and \(E_z\). These fields are used, in turn, to determine the 3-D modulated refractive index profile, which is subsequently used in computing the modulated effective index for use with the 2-D FDBPM.

The optical field that is input to the modulator is the fundamental TM-like mode with unit power, here called the eigenfunction \(U_0(x)\). This function can be determined by using the method described in Reference 10. The power of the fundamental mode guided by the modulator at any distance \(y\) can be calculated using the orthogonality principle from

\[
P(y) = \left| \int E(x,y) U_0^*(x) \, dx \right|^2
\]  

(3)

In our simulations, we use a 100 \(\mu\)m wide window with a transverse grid of 1000 points. An absorber is placed 15 \(\mu\)m from either side of the window edge to dampen the field preventing high frequency numerical instabilities\(^11\). The Y-branch spreads out in 0.1 \(\mu\)m steps and the power output is computed when the two arms are 40 \(\mu\)m apart so that the optical fields in the two arms no longer interact with each other.

<table>
<thead>
<tr>
<th>Table I Fabrication parameters for a Y-branch optical modulator</th>
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<tbody>
<tr>
<td>Ti thickness</td>
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<tr>
<td>bulk refractive index (n_b)</td>
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<tr>
<td>maximum refractive index (n_s)</td>
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<tr>
<td>diffusion depth (D)</td>
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<tr>
<td>diffusion temperature</td>
</tr>
<tr>
<td>diffusion time</td>
</tr>
<tr>
<td>waveguide pattern width (W)</td>
</tr>
<tr>
<td>electrode gap at input</td>
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<tr>
<td>electrode gap at output</td>
</tr>
<tr>
<td>branch angle (\theta)</td>
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<tr>
<td>electrode length</td>
</tr>
</tbody>
</table>
3. SIMULATION RESULTS

The goal of this numerical simulation is to study a Y-branch modulator combining short electrode lengths with high on/off ratios at intermediate voltages, i.e. about 50 V. We have found that generally, on/off ratios at any given applied voltage increase with increasing branch angle. However, the amount of guided power also decreases with increasing branch angle. A 2° branch angle is chosen for this particular study because it exhibits high on/off ratios while retaining about 50% of the input power as well as having short electrode lengths.

We have simulated the modulator using various electrode lengths, and found that a two-horn-length electrode provides better performance than a one-horn-length or three-horn-length electrode. A one-horn-length electrode is too short to cause substantial modulation, while a three-horn-length electrode shows no notable improvement in the on/off ratio but obviously increases the electrodes' capacitance.

The simulations show that both the on/off ratio and the percent guided power increase with applied voltage. For example, the on/off ratio is predicted to be 2.4:1 at 20 V with 37% guided power and 85:1 at 80 V with 51% guided power, as shown in Figure 2. The on/off ratio's increase with applied voltage is to be expected because the greater the electric field the greater the change in the refractive index and the more light directed into one of the arms. The relationship between applied voltage and guided power shows that guiding efficiency increases with voltage, this is because light which is originally radiated at low voltages is increasingly captured and channelled into one of the arms as the voltage is increased. Figures 3 and 4 show the optical field in the Y-branch with 0 V and 50 V applied respectively.

4. FABRICATION

A Y-branch optical modulator, having the parameters shown in Figure 1 and Table I, was fabricated on z-cut y-propagating LiNbO3. The Y-branch pattern was formed in the 500 Å thick Ti using photo-lithography and plasma-etching. The Ti was diffused into the crystal at 1050°C for 6 hours in flowing wet oxygen. The wet oxygen was used to prevent surface waveguiding due to LiO2 out-diffusion. The estimated maximum refractive index change due to the Ti-indiffusion is 0.004 at \( \lambda_0 = 632.8 \) nm.

Before putting on the electrodes, a thin SiO2 optical buffer layer was sputtered onto the sample. Then a 4000Å thick layer of aluminum was deposited and patterned into the electrodes using photo-lithography and chemical wet-etching. The samples were subsequently cut to the appropriate sizes, and the input and output ends of the waveguides were polished.
Figure 3 Optical field distribution of the Y-branch optical modulator with 0 V applied.

Figure 4 Optical field distribution of the Y-branch optical modulator with 50 V applied.
5. MEASURED RESULTS

Polarized light from a Helium-Neon laser ($\lambda_o = 632.8$ nm) was coupled into a single mode polarization-maintaining monomode fibre through a microscope objective. Next the light from the fibre was endfire coupled into the TM-like mode of the input waveguide of the Y-branch optical modulator. The output from the modulator was projected through a microscope objective and a polarizer onto a pinhole in front of the detector which was connected to a storage oscilloscope. The output power from the two branches of the modulator was equalized prior to voltage application. Using a waveform generator a slowly-varying triangular wave was applied to the electrodes of the optical modulator. The measured on/off ratios were 5:1 at 25 V, 12:1 at 50 V, and 60:1 at 75 V. Here we have accounted for the effects of the radiation modes since, in our case, the detector picked up both the guided TM-like mode as well as a portion of the radiation modes. Using our simulation results, the amount of radiation was calculated and used to adjust the measured data accordingly.

The percentage guided power can be obtained by maximizing the power at the output of the modulator and then maximizing the power at the output of a 4 $\mu$m straight waveguide, fabricated on the same substrate adjacent to the modulator, and comparing the two. Since the straight waveguide is adjacent to the Y-branch modulator, we assume that both waveguides have nearly identical guiding characteristics. The amount of guided power measured using the above method was 36% with 0 V and 43% with 75 V applied, again we accounted for the effects of the radiation modes. These measured on/off ratios and percent guided powers compare reasonably well with the theoretical values, see Table II.

A Y-branch optical modulator was modelled and its behavior simulated numerically using the 2-D FDBPM with the EIM. A device was then fabricated on $z$-cut LiNbO$_3$, having a 2$^\circ$ branch angle and an electrode length of 228 $\mu$m. On/off ratios of 5:1 at 25 V, 12:1 at 50 V, and 60:1 at 75V were measured for light at a wavelength of 632.8 nm. The measured results are in good agreement with the theoretical performance predictions.

### Table II
Performance comparison of the Y-branch optical modulator

<table>
<thead>
<tr>
<th></th>
<th>theoretical</th>
<th>experimental</th>
</tr>
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<tbody>
<tr>
<td>on/off ratio:</td>
<td></td>
<td></td>
</tr>
<tr>
<td>25 V</td>
<td>4</td>
<td>5</td>
</tr>
<tr>
<td>50 V</td>
<td>12</td>
<td>12</td>
</tr>
<tr>
<td>75 V</td>
<td>62</td>
<td>60</td>
</tr>
<tr>
<td>% guided power:</td>
<td></td>
<td></td>
</tr>
<tr>
<td>0 V</td>
<td>35%</td>
<td>36%</td>
</tr>
<tr>
<td>75 V</td>
<td>50%</td>
<td>43%</td>
</tr>
</tbody>
</table>

6. CONCLUSION

A Y-branch optical modulator was modelled and its behavior simulated numerically using the 2-D FDBPM with the EIM. A device was then fabricated on $z$-cut LiNbO$_3$, having a 2$^\circ$ branch angle and an electrode length of 228 $\mu$m. On/off ratios of 5:1 at 25 V, 12:1 at 50 V, and 60:1 at 75V were measured for light at a wavelength of 632.8 nm. The measured results are in good agreement with the theoretical performance predictions.
7. ACKNOWLEDGEMENT

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8. REFERENCES